

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: JAMMY et al  
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For: METHOD FOR FORMATION  
OF CRYSTALLINE SILICON



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Date: February 9, 2001

Assistant Commissioner for Patents  
Washington, DC 20231

CERTIFICATE OF MAILING  
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INFORMATION DISCLOSURE STATEMENT

Sir:

The following documents, also listed on Form PTO-1449 and of  
which a copy is enclosed, unless otherwise noted, are hereby cited  
pursuant to 37 CFR §1.56, §1.97 and §1.98, for consideration in the  
examination of the above-identified application and for the purpose of  
having them made of record.

These documents were cited in a European search report for a  
related application (copy enclosed) more than three months prior to  
the filing of this Information Disclosure Statement.

Please charge the required fees to Attorney's Deposit Account No.  
19-2179.

- A. E.P. Patent No. 0684637
- B. E.P. Patent No. 0637063
- C. XP000297634
- D. U.S. Patent No. 4277320
- E. U.S. Patent No. 6018174
- F. XP000687427

Respectfully submitted,

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